

University of Central Florida BID TABULATION

TITLE: Advanced Oxide Etch Tool

NUMBER: 2025-02OC **AGENT/COORDINATOR:** B. Orofino

OPENING DATE: 8/28/2025 **TIME:** 2:00PM EST

POSTING TIME / DATE:

FROM: September 26, 2025 @ 2:00 PM EST

TO: September 29, 2025 @ 2:00 PM EST

Page 1 of 2 Page(s)

Bid/Proposal tabulations with intended award(s) will be posted for review by interested parties on the Procurement Services solicitation webpage and will remain posted for a period of 72 hours. Failure to file a protest in accordance with BOG regulation 18.002, or failure to post the bond or other security as required in BOG regulation 18.003, shall constitute a waiver of protest proceedings.

INTENT TO AWARD

<u>Bidders</u>	<u>Total Price</u>							
Oxford Instruments America Inc.	\$489,000.00							
Plasma-Therm LLC	\$648,798.00							

REMARKS: Vendor circled in red indicate intended award

PUR (Rev.07/24/17)